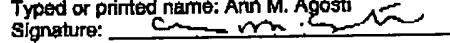


Application No.: 09/639,636

RD25905-6

OFFICIAL

I hereby certify that this correspondence is being facsimile transmitted to the TC1700 Before Final Facsimile Number 703 872 9310 of the United States Patent and Trademark Office on 20 February 2003. (9 pages total)
Typed or printed name: Ann M. Agosti
Signature: 


2/22/03**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Guida et al.

: Group Art Unit: 1722

Application No. 09/639,636

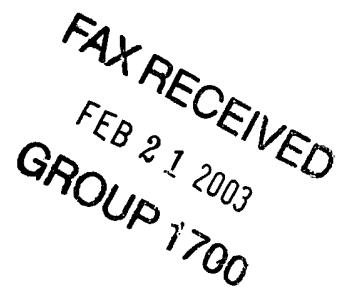
: Examiner: Luk, Emmanuel S.

Filed: 15 August 2000

: Response to Paper No. 5

For High Resolution Anti-Scatter X-ray
 Grid and Laser Fabrication Method**AMENDMENT UNDER 37 CFR 1.111**Assistant Commissioner for Patents
Washington, DC 20231

In response to the Office Action dated 21 November 2002, please amend the above-identified application by amending the title, canceling claims 1-9, and amending claims 15-17 as indicated in the Listing of Claims.


FEB 21 2003
GROUP 1700

Application No.: 09/639,636

RD25905-6

LISTING OF REPLACEMENT TITLE

System for Fabricating High Resolution Anti-Scatter X-ray Grid and Laser Fabrication Method